PATENT APPLICATION

00862.023488

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Haruhito ONO et al.	: Examiner: Unassigned)
Application No.: 10/787,082	: Group Art Unit: Unassigned)
Filed: February 27, 2004	·)
For: DEFLECTOR, METHOD OF MANUFACTURING DEFLECTOR, AND CHARGED PARTICLE BEAM EXPOSURE APPARATUS USING DEFLECTOR	
Commissioner for Patents P.O. Box 1450 Alexandria VA 22313-1450	

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed PTO-1449 form.

Applicants request that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.

This Information Disclosure Statement is being filed before the issuance of a first Office Action on the merits. Therefore, no fee under 37 C.F.R. 1.97(c)(2) is believed due. Nevertheless, the Commissioner may charge Deposit Account No. 06-1205, should any fee be due for filing this paper.

Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants Steven E. Warner

Registration No. 33,326

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U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE RADEMARK

LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)

April 28, 2004

ATTY DOCKET NO. 00862.023488

APPLICATION NO. 10/787,082

APPLICANT Haruhito ONO et al.

FILING DATE February 27, 2004

GROUP Unassigned

		U.	S. PATENT DOCUMENTS			
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	US-6,603,128 B2	08/05/2003	Maehara et al.	250	441.11	
	US-6,559,463 B2	05/06/2003	Ono et al.	250	492.22	
	US-6,335,127 B1	01/01/2002	Ono	430	5	
	2003/0209673 A1	11/13/2003	Ono et al.	250	396 R	
	2002/0005491 A1	01/17/2002	Yagi et al.	250	396 ML	
	2002/0000766 A1	01/03/2002	Ono et al.	313	240	
	2001/0054690 A1	12/27/2001	Shimada et al.	250	306	
	2001/0052576 A1	12/20/2001	Shimada et al.	250	492.1	
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		FORI	EIGN PATENT DOCUMENTS		· · · · · · · · · · · · · · · · · · ·	
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATIO YES/NO/ OR ABSTRAC
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	ОТІ	HER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)			
EXAMINER			DATE CONSIDERED			

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet_1_ of _1_